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Attorney Docket No.  
SEL 123

Serial No.  
09/241,695

Applicant  
Akiharu MIYANAGA

Filing Date  
February 2, 1999

Group  
2811

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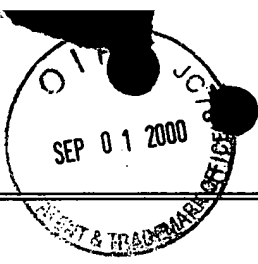
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Shouxiang He

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EXAMINER:

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